

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of  
Hiroyuki Fujimura, et al

Serial No.: 10/540,640

Art Unit: 1775

Filed: March 29, 2006

Examiner: A. Turner

For: DIAMOND-COATED SILICON AND  
MANUFACTURING METHOD THEREOF

**VIA EFS-Web**  
**Total Pages: 9**

**REPLACEMENT PRELIMINARY AMENDMENT**

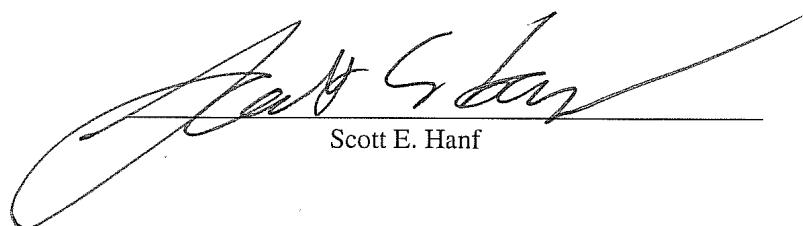
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This Replacement Preliminary Amendment is being filed in response to the Notice of Non-Compliant Amendment dated January 31, 2007. Please amend the application as follows.

**CERTIFICATE OF EFS TRANSMISSION**

I hereby certify that this correspondence is being filed electronically with the United States Patent and Trademark Office on February 6, 2007.



Scott E. Hanf